

## Sheet 1 of 1

**FORM PTO-1449** 

INFORMATION DISCLOSURE

STATEMENT BY APPLICANT(S)

Atty Docket No.

: 29273/502

Serial No.

Inventors

: H. KAWANO et al.

Filed

: 21 May 1999

**Group Art Unit** 

Examiner

## **U.S. PATENT DOCUMENTS**

Examiner	Patent	Patent		Class/ Filing
Initial,	<u>Number</u>	<u>Date</u>	Name	Subclass Date
_ Kr	5,149,975	09/22/92	YODA et al.	250/492.2
164	5,278,421	01/11/94	YODA et al.	250/492.2
'KF	4,463,265	07/31/84	OWEN et al.	250/492.2
<u> </u>	5,760,410	06/02/98	MATSUKI et al.	250/492.2

## **FOREIGN PATENT DOCUMENTS**

Examiner	Document			Class/	Translation
<u>Initial</u>	<u>Number</u>	<u>Date</u>	Country	<u>Subclass</u>	Yes No
101-	3-225816	10/04/91	Japan		ABS.
KF	8-213315	08/20/96	Japan		ABS.
XF	10-229047	08/25/98	Japan		ABS.
LF.	62-046059	09/30/87	Japan		ABS.
' <u>r</u> -	63-014866	04/01/88	Japan		ABS.
CE	5-160010	06/25/93	Japan		ABS.
KF	9-293670	11/11/97	Japan		ABS.

## **OTHER DOCUMENTS**

(Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner Initial

Murai et al.: Fast proximity effect correction method using a pattern area density map, J. Vac.Sci. Technol. B 10 (6), Nov/Dec. 1992; pp. 3072-3076

**EXAMINER** 

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 191573\29273/502